

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/657,261	KIM ET AL.	
Examiner	Art Unit	
Khai M. Nguyen	2617	

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SEARCHED						
Class	Subclass	Date	Examiner			
455	450 554.1 555 550.1 455 463	7/20/2006	KN			
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DA1		EXMR	
East (see attached)	7/20/2	2006	KN	
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